



EPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Matthew Prince et al.

Serial No.: 10/762,849

Filed: January 22, 2004

For: Reducing Wafer Defects  
from Chemical  
Mechanical Polishing

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Art Unit: 3723

Examiner: Hadi Shakeri

Docket: ITL.0941US  
P15694

Assignee: Intel Corporation

Mail Stop **Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY TO OFFICE ACTION**

Sir:

In response to the office action mailed May 9, 2006, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made.

Date of Deposit: July 13, 2006

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Cynthia L. Hayden*  
Cynthia L. Hayden